

Docket No.: 8733.311.10-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Lim Su LEE

Confirmation No.: TBA

Application No.: TBA

Group Art Unit: TBA

Filed: August 26, 2003

Examiner: TBA

For: APPARATUS AND METHOD FOR
CLEANING SUBSTRATE

Customer No.: 30827

CLAIM FOR PRIORITY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

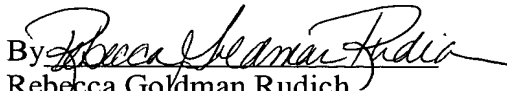
Applicant hereby claims priority under 35 U.S.C. 119 based on the following prior foreign application filed in the following foreign country on the date indicated:

<u>Country</u>	<u>Application No.</u>	<u>Date</u>
Korea	1999-44599	October 10, 1999

In support of this claim, Certified copies of the corresponding Convention Application(s) were filed in prior application Serial No. 09/689,839, filed October 13, 2000.

Dated: August 26, 2003

Respectfully submitted,

By 
Rebecca Goldman Rudich
Registration No.: 41,786
MCKENNA LONG & ALDRIDGE LLP
1900 K Street, N.W.
Washington, DC 20006
(202) 496-7500
Attorneys for Applicant



30827

PATENT TRADEMARK OFFICE